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## \*BIBDATASHEET\*

CONFIRMATION NO. 6935

Bib Data Sheet

SERIAL NUMBER 10/759,093	FILING DATE 01/20/2004  RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. SEC.889D
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APPLICANTS

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\*\* CONTINUING DATA ..... *MK (Verified)*  
 This application is a DIV of 10/012,564 12/12/2001 PAT 6,701,942

\*\* FOREIGN APPLICATIONS ..... *MK (Verified)*  
 REPUBLIC OF KOREA 2001-16327 03/28/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 04/21/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>[Signature]</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 4	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 1
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TITLE  
 Method of and apparatus for removing contaminants from surface of a substrate

<input type="checkbox"/> All Fees
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